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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.			
10/767,625	01/28/2004	Srinivasamohan Narayanan	SL1207 5653				
75	90 10/06/2005	EXAMINER					
BP America Ir	BP America Inc.			MENZ, DOUGLAS M			
Docket Clerk							
BP Legal, M.C	5 East	ART UNIT	PAPER NUMBER				
4101 Winfield I	Road	2891					
Warrenville, IL 60555			DATE MAILED: 10/06/2005				

Please find below and/or attached an Office communication concerning this application or proceeding.

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Office Action Summany		Appl	Application No.		Applicant(s)			
		10/7	67,625	N	NARAYANAN ET AL.		(hy	
	Office Action Summary	Exar	niner	A	art Unit			
			glas M. Menz	_	891			
: ۔۔ Period for I	The MAILING DATE of this communicat Reply	ion appears o	on the cover sheet	with the con	respondence ac	dress -		
WHICH - Extensio after SIX - If NO pe - Failure to Any repl	RTENED STATUTORY PERIOD FOR EVER IS LONGER, FROM THE MAIL ns of time may be available under the provisions of 37 (6) MONTHS from the mailing date of this communic riod for reply is specified above, the maximum statutor or reply within the set or extended period for reply will, by received by the Office later than three months after that term adjustment. See 37 CFR 1.704(b).	ING DATE O 7 CFR 1.136(a). In ation. ry period will apply by statute, cause the	OF THIS COMMUN in no event, however, may and will expire SIX (6) Mo the application to become	NICATION. a reply be timely ONTHS from the ABANDONED	filed mailing date of this c 35 U.S.C. § 133).	·		
Status								
1)⊠ R	esponsive to communication(s) filed o	n 20 June 20	105					
	7							
	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
OII	osed in accordance with the practice t	inuel Ex part	e Quayle, 1935 C	.D. 11, 455	J.G. 213.			
Disposition	of Claims							
4)⊠ CI	aim(s) <u>1-27</u> is/are pending in the appl	ication.						
4a	4a) Of the above claim(s) <u>1-16 and 22-27</u> is/are withdrawn from consideration.							
5)∏ CI	aim(s) is/are allowed.							
6)⊠ CI	☑ Claim(s) <u>17-21</u> is/are rejected.							
7)□ CI	aim(s) is/are objected to.							
8) <u></u> CI	aim(s) are subject to restriction	and/or elect	ion requirement.					
Application	Papers							
9)□ Th	e specification is objected to by the Ex	vaminer						
•	e drawing(s) filed on 28 January 2004		accepted or h)	objected to	by the Evamin	ner		
	plicant may not request that any objection			-	-	ici.		
	eplacement drawing sheet(s) including the					ED 1 191	1(4)	
	e oath or declaration is objected to by							
		THE EXCHANGE	Hote the attach	ed Office Ac		10-102.		
	ler 35 U.S.C. § 119							
	knowledgment is made of a claim for the	foreign priorit	y under 35 U.S.C.	. § 119(a)-(d) or (f).			
	All b) Some * c) None of:							
	Certified copies of the priority doc							
2.	<u> </u>			• •				
3.	Copies of the certified copies of the			en received i	n this National	Stage		
	application from the International	•	` ''					
* See	the attached detailed Office action fo	r a list of the	certified copies no	ot received.				
Attachment(s)								
1) Notice of	References Cited (PTO-892)		4) Interview	V Summary (PT	O-413)			
	Draftsperson's Patent Drawing Review (PTO-	Paper No	o(s)/Mail Date.	·				
	on Disclosure Statement(s) (PTO-1449 or PTO o(s)/Mail Date <u>5/9/05, 8/10/04</u> .	/SB/08)	5)		nt Application (PTC	J-152)		
			<u>-,</u>					

DETAILED ACTION

Election/Restrictions

Applicant's election with traverse of Species IIa of Group II, claims 17-21, in the reply filed on 6/20/05 is acknowledged. The traversal is on the ground(s) that the Examiner has not shown enough evidence to support the restriction. This is not found persuasive because it has been shown in paper dated 5/19/05 that a restriction requirement was proper. To further expand on the restriction requirements as to the product and process of making, the product as claimed does not require the removal of a second dopant from the back surface. Therefore, a process which incorporates a masking of the back surface prior to the forming of the first layer would constitute a materially different process of manufacturing the product as claimed. Regarding the Species restriction, the dividing of related inventions is proper on the grounds that different fields of search are necessary given the fact that different limitations are claimed.

The requirement is still deemed proper and is therefore made FINAL.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

⁽b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 17 and 21 are rejected under 35 U.S.C. 102(b) as being anticipated by Fraas et al. (US 5091018).

Regarding claim 17, Fraas et al. (US 5091018) discloses a process for making a photovoltaic device using a substrate comprising silicon doped with a first dopant (Col. 6, lines: 18-30), the process comprising the steps of:

- (a) forming a first layer (64, Fig. 8A) of the substrate (61, Fig. 8A), the first layer comprising a second dopant (p-type) of a conductivity type opposite the first dopant (n-type) (Col. 6, lines: 58-65);
- (b) forming a surface coating (62, Fig. 8A) disposed over the substrate such that a back surface of the substrate is free or substantially free of the surface coating (Col. 6, lines: 36-40); and
- (c) removing the second dopant from the back surface (65, Fig. 8A-B) such that the back surface is free or substantially free of the second dopant (Col. 7, lines: 1-18).

Regarding claim 21, Fraas further discloses wherein the surface coating (62) comprises silicon nitride (Col. 6, lines: 36-39).

Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the

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invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

This application currently names joint inventors. In considering patentability of the claims under 35 U.S.C. 103(a), the examiner presumes that the subject matter of the various claims was commonly owned at the time any inventions covered therein were made absent any evidence to the contrary. Applicant is advised of the obligation under 37 CFR 1.56 to point out the inventor and invention dates of each claim that was not commonly owned at the time a later invention was made in order for the examiner to consider the applicability of 35 U.S.C. 103(c) and potential 35 U.S.C. 102(e), (f) or (g) prior art under 35 U.S.C. 103(a).

Claims 18-20 are rejected under 35 U.S.C. 103(a) as being unpatentable over Fraas et al. (US 5091018) in view of Rittner (US 4135950).

Regarding claim 18, Fraas discloses the process of claim 17 as mentioned above. However, Fraas does not disclose further comprising the step of texturing the substrate.

Rittner discloses a silicon solar cell structure wherein the substrate is textured (Fig. 2 and Col. 2). Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to texture Fraas's substrate as taught by Rittner because Rittner explicitly discloses that such features are for optimizing the power output of the solar cell throughout its design lifetime (Col. 2, lines: 55-65).

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Regarding claim 19, Rittner further discloses the process of removing the texture from the back surface such that the back surface is substantially smooth (Fig. 2 and Col. 1, lines: 54-55 and Col. 2, lines: 40-45). It would have been obvious to one of ordinary skill in the art at the time the invention was made to remove the texture from the back surface such that the back surface is substantially smooth because Rittner explicitly discloses such a step in the process of forming an electron reflecting region (Col. 2, lines: 40-46).

Regarding claim 20, Rittner further discloses the step of forming a back surface field (p+ region, Fig. 2 and Col. 2, lines: 40-47). It would have been obvious to one of ordinary skill in the art at the time the invention was made to incorporate a back surface field into Fraas's device for the purpose of increasing the efficiency of the device. To further support the Examiner's position that Rittner's p+ region constitutes a back surface field used to increase the efficiency of the device see Mowles (US 6541695) (Fig. 2A and Col. 10, lines: 5-20).

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Douglas M. Menz whose telephone number is 571-272-1877. The examiner can normally be reached on M-F 8-5.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Bill Baumeister can be reached on 571-272-1722. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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